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Date : January 8, 2009
TO : Director, Office of Patent Publication
FROM : Office of Petitions
SUBJECT : Withdrawal from Issue of Application No. 10/589,390
Applicant(s) : Shigeki Imai et al
Application No. : 10/589,390
Filed : August 15, 2006

The above-identified application has been assigned Patent No. 7,482,213 and an issue date of January 27, 2009.

It is hereby directed that this application be withdrawn from issue at the request of the applicant. Do not refund the issue fee.

The following erratum should be published in the Official Gazette if the above-identified application is published in the OG of January 27, 2009:

"All reference to Patent No. 7,482,213 to Shigeki Imai et al of Japan for THIN FILM TRANSISTOR, METHOD OF MANUFACTURING SAME, DISPLAY DEVICE, METHOD OF MODIFYING AN OXIDE FILM, METHOD OF FORMING AN OXIDE FILM, SEMICONDUCTOR DEVICE, METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE, AND APPARATUS FOR MANUFACTURING SEMICONDUCTOR DEVICE appearing in the Official Gazette of January 27, 2009 should be deleted since no patent was granted."

/Karen Creasy/
Karen Creasy
Petitions Examiner
Office of Petitions

cc: Paul Harrison
Deneise Boyd
Mary Louise McAskill
Niomi Farmer
Mary E. Johnson (Cookie)
Duane Davis (CDS)
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